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RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 2851

#22
8/1/01
R 1.116
EDURE
UP 2851

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Tomoharu HASE) : Examiner: H. NGUYEN
Application No.: 09/145,982 /) : Group Art Unit: 2851
Filed: September 3, 1998 /) : July 25, 2001
For: EXPOSURE APPARATUS AND)
DEVICE MANUFACTURING METHOD)
INCLUDING GAS PURGING OF A SPACE)
CONTAINING OPTICAL COMPONENTS)

Commissioner for Patents
Box AF
Washington, D.C. 20231

PETITION UNDER 37 C.F.R. § 1.136(a)

Sir:

Applicant petitions the Commissioner for Patents to extend the time for response to the final Office Action dated March 27, 2001 for one month from June 27, 2001 to July 27, 2001.

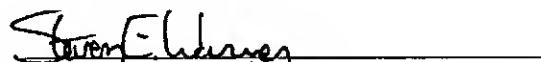
Submitted herewith is a check for \$110.00 to cover the fee for the extension under 37 C.F.R. § 1.17. Any deficiency in or overpayment of this fee should be charged or credited to Deposit Account No. 06-1205. A duplicate of this petition is enclosed.

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120.00 OP

Applicant's undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Attorney for Applicant
Steven E. Warner
Registration No. 33,326

FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
New York, New York 10112-3801
Facsimile: (212) 218-2200

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